

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10598035	
	Filing Date		2006-08-16	
	First Named Inventor	DIRKSEN		
	Art Unit			
	Examiner Name			
	Attorney Docket Number		NL040205	

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	1	20010053489	A1	2001-12-20	DIRKSEN P. ET AL	

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FOREIGN PATENT DOCUMENTS								
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	1	GB2320768		A	1998-07-01	HYUNDAI ELECTRONICS INDUSTRIES., LTD.		<input type="checkbox"/>
	2	EP0659810		A	1995-06-21	ZEISS, CARL		<input type="checkbox"/>
	3	WO20030056392		A1	2003-07-10	KPENV		<input type="checkbox"/>

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10598035	10598035 - GAU: 4182
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	1	DIRKSEN, J. ET AL: "ABERRATION RETRIEVAL USING THE EXTENDED NIJBOER-ZERNIKE APPROACH"; JOURNAL OF MICROLITHOGRAPHY, MICROFABRICATION AND MICROSYSTEMS, VOL. 2 ISSUE 1, PP. 61-68, JANUARY 2003.		<input type="checkbox"/>
	2	AHN, CHANG-NAM ET AL: "A NOVEL APPROXIMATE MODEL FOR RESIST PROCESS"; HYUANDAI ELECTRONICS INDUSTRIES CO., LTD; SPIE VOL. 3334, PP. 752-763.		<input type="checkbox"/>
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